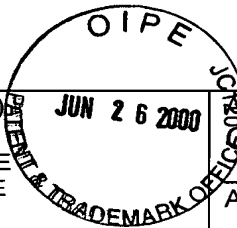


FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))Attorney Docket No.:
GR 96 P 8091 PSerial No.
09/283,907

Applicant

Michael Kelly et al.

Filing Date
April 1, 1999Group Art Unit
2812

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	6,071,795	06/06/00	Cheung et al.			
	B						
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		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	0 987 741 A1	03/22/00	Europe			X
	K						
	L						
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

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EXAMINER

DATE CONSIDERED

September 25, 2001

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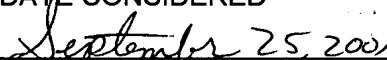
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	C.R. Miskys et al.: "MOCVD-Epitaxy on Free-Standing HVPE-GaN Substrates", phys. stat. sol. (a) 176, 443 (1999), pp. 443-446
	P	L. Tsakalakos et al.: "Epitaxial ferroelectric (Pb,La)(Zr,Ti)O ₃ thin films on stainless steel by excimer laser liftoff", Applied Physics letters, Volume 76, number 2, January 10, 2000, pp. 227-229

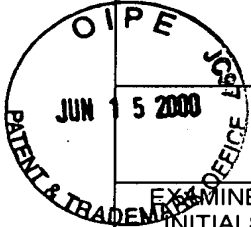
EXAMINER



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EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	4,448,636	05/84	Baber	—	—	
	B	4,883,561	11/89	Gmitter et al.	—	—	
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	J	3508469A1	09/86	Germany	—	—	X
	K	0718885A2	06/96	Europe	—	—	X
	L						
	M						
	N						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	1	"Optical patterning of GaN films", M.K. Kelly et al., Appl. Phys. Lett. 69 (12), September 16, 1996, pp. 1749-1751					
	2	"Extreme selectivity in the lift-off of epitaxial GaAs films", Eli Yablonovitch et al., Appl. Phys. Lett. 51 (26), December 28, 1987, pp. 2222-2224					
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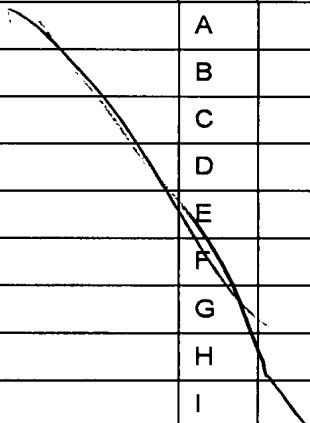
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	3	"On the Thermal Decomposition of GaN in Vacuum", R. Groh et al., pp. 353-357					
	4	"Few Characteristics of Epitaxial GaN-Etching and Thermal Decomposition", Yasua Morimoto, J. Electrochem. Soc.: Solid-State Science and Technology, October 1974, pp. 1383-1384					
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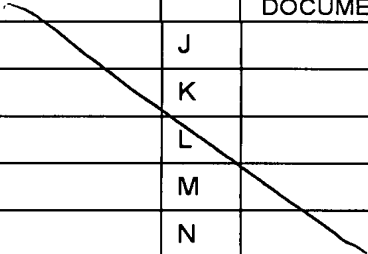
SHEET 3 OF 4 11/8/99

FORM PTO-1449 (SUBSTITUTE)	Attorney Docket No.: GR 96 P 8091	Appl. No. 09/283,907
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	Applicant MICHAEL KELLY ET AL.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Filing Date APRIL 1, 1999	Group Art Unit



A. Jenkins

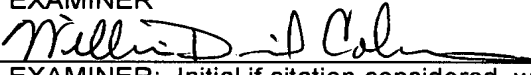
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	5	"Photoassisted dry etching of GaN", R.T. Leonard et al., Appl. Phys. Lett. 68, February 5, 1996, pp. 794-796
	6	"Laser-Induced Dry Lift-off Process", Young-Feng Lu et al., Jpn. J. Appl. Phys. Vol. 34, 1995, pp. 1669-1670

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
	1	"Excimer-Laser Removal of SiO ₂ Patterns from GaAs Substrates", Young-Feng Lu et al., Jpn. J. Appl. Phys., Vol. 33, 1994, pp. 324-327

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